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**APPLICANT**  
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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
/AB/	H09-073001	03/18/1997	Japan	↓	↓	Abstract	
/AB/	H09-165231	06/24/1997	Japan	↓	↓	Abstract	
/AB/	H10-186104	07/14/1998	Japan	↓	↓	Abstract	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER /Alain Bashore/ (10/18/2007)

DATE CONSIDERED

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